NOTES:

1. SUBSTRATE:

FUSED SILICA

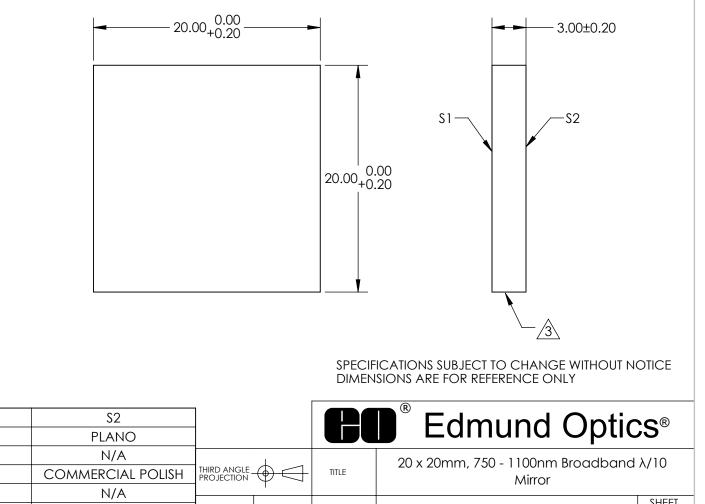
2. COATING (APPLY ACROSS CLEAR APERTURE)

S1:DIELECTRIC MIRROR (750-1100nm) R(AVG) >98% @ 750 - 1100nm @ 0 - 45° AOI R(AVG) >99% @ 750 - 1100nm @0° AOI

S2: NONE

3. FINE GRIND SURFACE (ADD INK NOTE AS NEEDED)

4. ROHS COMPLIANT



FOR INFORMATION ONLY. **DO NOT MANUFACTURE** PARTS TO THIS DRAWING

SHAPE	S1 PLANO	S2 PLANO			Edmund Optic	CS [®]
CLEAR APERTURE (%)	90			TITLE	20 x 20mm, 750 - 1100nm Broadband	λ/10
SURFACE QUALITY	<u>20 - 10</u> λ/10	COMMERCIAL POLISH		IIILE	Mirror	
BEVEL	PROTECTED AS NEEDED	PROTECTED AS NEEDED	ALL DIMS IN mm	DWG NO	29928	SHEET 20 OF 24